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Ionic liquid gating of InAs nanowire-based FETs

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Figure of merit: $ZT = \frac{S^2 \sigma}{k_l + k_e} T$





Figure of merit:







PISA

NW Thermoelectrics







S.Roddaro, et al., Nano Research 2014



PISA

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S.Roddaro, et al., Nano Research 2014



SUPPORTED NW devices: Seebeck & Power Factor





S.Roddaro, et al., Nano Research 2014





SUPPORTED NW devices: Seebeck & Power Factor

Figure of merit:



SUSPENDED NW devices: thermal conductivity







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SUSPENDED NW devices: thermal conductivity

Optical approach







SUPPORTED NW devices: Seebeck & Power Factor

Figure of merit:



SUSPENDED NW devices: thermal conductivity

Optical approach

All-electrical method: Current injection at freq ω Voltage probing at freq 3ω







Suspended NW devices: strategies for gating?



backgate, side gates



poor modulation of σ at temperatures of interest



15% *R* modulation within +/- 20V (combining BG and SG)





Ionic liquid gating







PISA

Ionic liquid gating









PISA

Ionic liquid gating











Zoology of ionic liquids

CATIONS

ANIONS



































































Hysteresis (getting rid of)





Parameter space:

Temperature



Hysteresis (getting rid of)



 $V_{\rm LG}\,({\rm V})$ 0 -1 -1 0 1 -1 0 1 -1 0 1 1 2.4 4 mV/s 2.2 $I_{\rm DS}(\mu {\rm A})$ 2.0 1.8 300 K 240 K 235 K 230 K 2.4 240 K $I_{\rm DS}(\mu {\rm A})$ 2.2 2.0 9 mV/s61 mV/s 41 mV/s 143 mV/s

Parameter space:

Temperature

 dV_{LG}/dt (liquid gate voltage Sweep rate)





Hysteresis (getting rid of)



Parameter space:

Temperature

 dV_{LG}/dt (liquid gate voltage Sweep rate)

T = 240 K dV_{LG}/dt < 10 mV/s





Hysteresis (analysis)









Hysteresis (analysis)











D. Prete et al., *AIP Proceeding* 2019 L. Bellucci, D. Prete et al., in preparation (2018)





DFT

Hexafluorophosphate (coarse grain) + layered electrodes + porosity

Molecular dynamics diffusion coefficients

V. Tozzini





L. Bellucci





Many additional problems in simulations!

- ✓ realistic structure of the porosity (\rightarrow sponge builder)
- ✓ Size of the system
- The model of electrode must be polarizable



Tests to

- validate the model
- optimize the simulation parameters

Test with mechanically induced diffusion: anion has a larger diffusivity than the cation

Test with nanoporous charged polarizable electrodes











Ionic Liquid Gate vs back gate









 $\label{eq:massessed} \begin{array}{l} \mu \approx 200 \ cm^2/Vs \\ C_{BG} \approx 60 \ aF \end{array}$





Gate induced transition









Summary & perspectives



The happy marriage btwn III-V NWs & ionic liquids

- control of hysteresis
- FET operation demonstrated
- Ionic liquid gate versus BG: no match!
- Onset of charge induced phase transition
- Gate-electrode geometry optimization
- Suspended NW thermoelectrics
- Charge induced phase transition in 2D and 1D
- Ambipolar transport
- Dynamically controlled p-n junctions





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Gate-electrode geometry optimization



Liquid gating performance affected by:

gate-electrode distance from the NW ?



gate-electrode area?





Acknowledgements



Valeria Demontis



Domenic Prete





Valentina Zannier



Daniele Ercolani



Stefan Heun



Lucia Sorba



Fabio Beltram



Shimpei Ono





V. Tozzini





L. Bellucci













Principles of TE: Microscopic origins



Power factor

 σS^2

Electrical conductivity

$$\sigma = \frac{e^2}{3} \int \tau(E) v^2(E) \left(-D(E) \frac{df_0}{dE} \right) dE$$

requires large area under differential conductivity (green line)

• Seebeck coefficient

$$S = -\frac{e}{3T\sigma} \int \tau(E) v^2(E) \left(-D(E) \frac{df_0}{dE} \right) (E - E_f) dE$$

requires asymmetry in differential conductivity at E_F (blue area)

• Thermal conductivity $k = \frac{1}{d} \frac{\partial}{\partial T} \int Ef(E) g(E) \nu(E) \Lambda(E) dE$



Quantum confinement !? S \uparrow $k \downarrow$





PISA

$ZT = \frac{S^2 \sigma}{k_e + k_l} T$

Approaches to k lowering



Materials with structural disorders and phonon scattering centers (es. grain boundaries, nanocomposites, superlattices etc)

Nanostructures with one or more dimensions smaller than the phonon mean free path $\Lambda(E)$ but larger than that of electrons and holes

Electron crystal - phonon glass

Nanostructured semiconductor







Nature Materials 14, 667-674 (2015)



 In NWs low dimensionality allows to reduce k thanks to the increased phonon-boundary scattering

• NWs can be "easily" further nanostructured in their length, in order to exploit other quantum effects useful in TE field, such as confinement, phonon scattering in superlattices, field effect etc.



Nanowires are ideal nanostructures to explore the effects of low-dimensionality on thermoelectric behavior



All-Electrical Measure of k: 3ω -Method





 $V_{3\omega} = V_{0,3\omega} \sin(3\omega - \varphi)$

* valid for high aspect ratio conductors

The fit of the experimental curve using:^{*}

$$V_{0,3\omega} \approx \frac{4I_0^3 R R' L}{\pi^4 k_t A}$$

where L = conductor lenght A = conductor section area

provides the value of k

L. Lu, et al., Rev. Sci. Instrum., 72, 2996 (2001) J. Kimling, et al., Rev. Sci. Instrum. 82, 074903 (2011) G. Pennelli, et al., J. Appl. Phys. 115, 084507 (2014)





±3.000e+02



T-dependence of R







$V_{3\omega}$ versus I_0 : estimate of k







The whole protocol for measuring thermal conductivity in suspended NW devices is tested, works fine





CS-NW device

Demonstration of 1D-1D-drag phenomena in self-assembled NWs



Unveiling TE effects in Coulomb-coupled 1D systems









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Francesco Rossella

NEST, Scuola Normale Superiore and Istituto Nanoscienze-CNR Pisa, Italy



NEST, Scuola Normale Superiore & Istituto Nanoscienze-CNR



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PER LA NANOSCIENZA ANNO - 2016

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Materials: self-assembled NW heterostructures







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- > Technology: field effect controlled NW-based devices





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- Implementation:
 - I. hemogeneous nanowires
 - II. InAs/InP axial heterostructures
 - III. InAs/InP/GaSb radial heterostructures
 - IV. Hybrid metal/semiconductor axial heterostrictures













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- Technology: field effect controlled NW-based devices
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Lucia Sorba

- Chemical beam epitaxy
- III-V Semiconductors
- Self-assembled nanocrystals (bottom-up approach)

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Au catalyst

18-71 (5)910

















Au thin film



position













Au thin film



SST 30, 115012 (2015)









Radial heterostructures: core-shell NWs







Tunable Esaki effect

Mirko

Rocci

- Thermoelectrics in coupled 1D systems
- 1D-1D Coulomb drag

S.Pezzini, ... and F.Rossella, in preparation M.Rocci, F.Rossella* *et al., Nano Lett.* **16**, 7950 (2016)







Axial heterostructures

GaAs/InAs



Sharp interface between 2 semiconductors







Axial heterostructures



GaAs/InAs InAs/InP



S. Roddaro



Sharp interface between 2 semiconductors

InP **barriers** few nm thick inside an InAs NW

Tunneling processes in 0D and 1D (NW-QDs)





Axial heterostructures





GaAs/InAs







Sharp interface between 2 semiconductors

InP **barriers** few nm thick inside an InAs NW

Metal/semiconductor junctions

- ➤ Tunneling processes in 0D and 1D (NW-QDs)
 ➤ Shottcky barriers → light emission, optoelectronics
- J. David, F. Rossella* et al, Nano Lett. 17, 2336 (2017)
- F. Rossella* et al, Nano Lett. 16, 5521 (2016)
- F. Rossella et al, Nat. Nanotech. 9, 997 (2014); F. Rossella et al, J. Phys. D: Appl. Phys. 47 394015 (2014)
- L. Romeo et al., Nano Lett. 12, 4490 (2012); S. Roddaro et al., Nano Lett. 11, 1695 (2011)



Homostructures: graded n-type doping



- > $n(x) \rightarrow \epsilon(x) \rightarrow tailoring dielectric response$
- Semiconductor → gate-tunable nano-plasmonics

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A.Arcangeli, F. Rossella* et al, Nano Lett. 16, 5688 (2016)